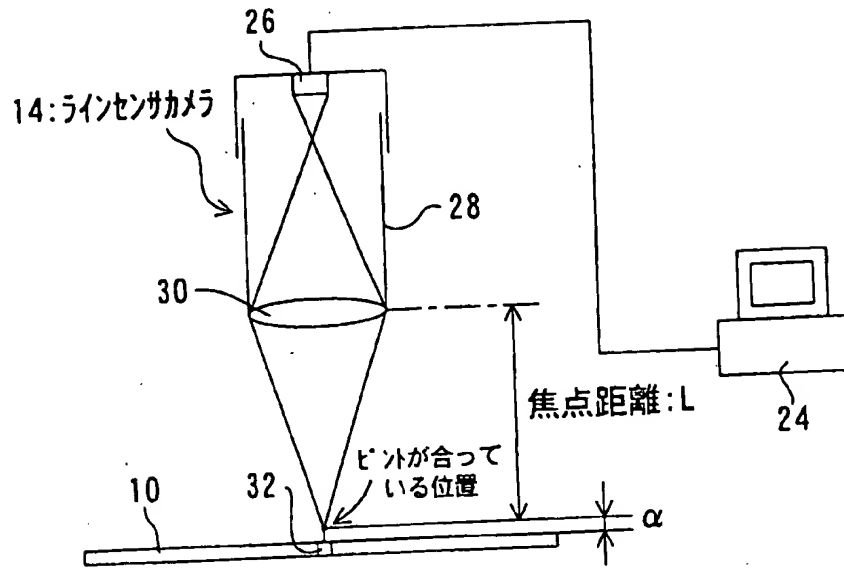


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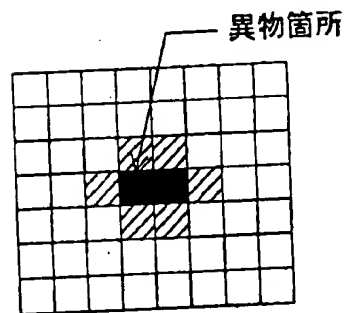
Fig. 1

(1)



ピントをずらした状態(ワーク表面+ α)

(2)

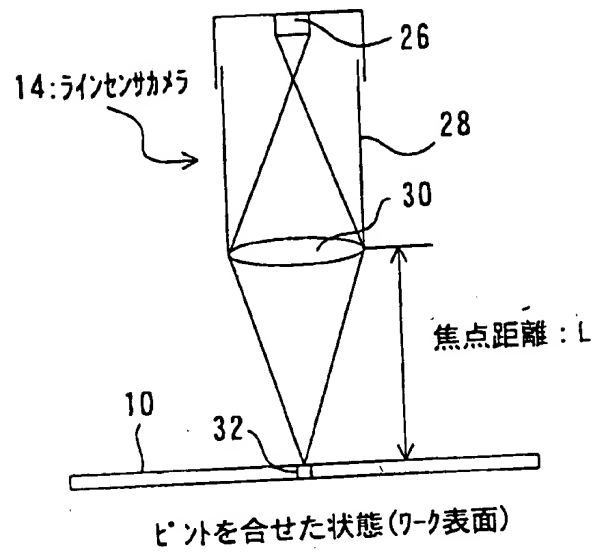


ピントをぼかした条件
(異物サイズ:8画素)

Fig. 2

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(1)



(2)

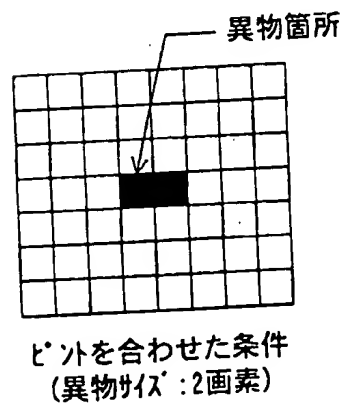


Fig. 3

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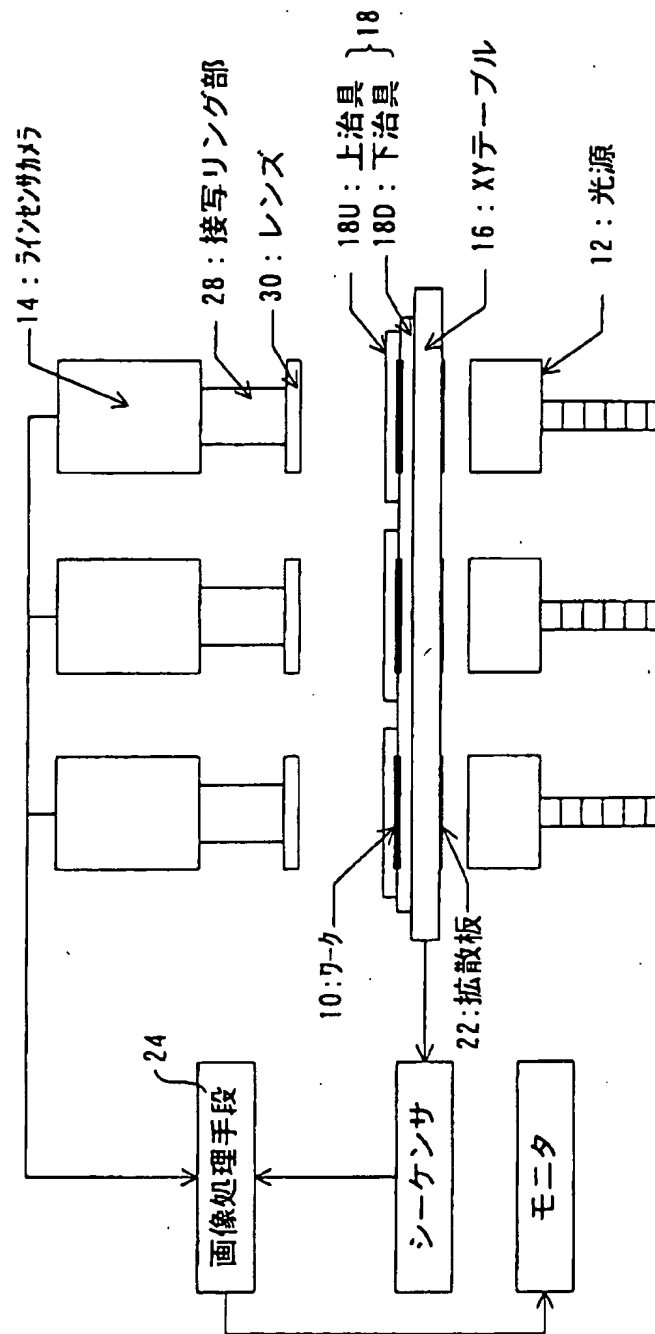


Fig. 4

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